

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 295727US0PCT		SERIAL NO. 10/594,282	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Hirotoishi ISHII, et al.			
				FILING DATE September 26, 2006		GROUP 1752	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
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	AC						
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FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AD						
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	AG						
	AK						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
/SL/	AW	Osamu HABA, et al., "A New Photoresist Based on Calix [4] resorcinarene Dendrimer", CHEMISTRY OF MATERIALS, VOL. 11, No. 2, XP-002470141, 1999, pages 427-432					
	AX						
	AY						
	AZ						<input type="checkbox"/> Additional References sheet(s) attached
Examiner /Sin Lee/					Date Considered 04/27/2008		
*Examiner, Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /SL/